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Docket No.: 60188-084

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	Customer Number: 20277	RECEIVED
Shigeki FURUYA, et al.	:	Confirmation Number: 1398	JUL 06 2004
Serial No.: 09/922,671	:	Group Art Unit: 2815	TECH CENTER 2800
	:	Allowed: June 14, 2004	
Filed: August 07, 2001	:	Examiner: Matthew E. WARREN	

For: CMOS BASIC CELL AND METHOD FOR FABRICATING
SEMICONDUCTOR INTEGRATED CIRCUIT USING THE SAME

REQUEST FOR ACKNOWLEDGEMENT OF THE CITED ART

Mail Stop ISSUE FEE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

We are in receipt of the Notice of Allowance dated June 14, 2004.

In reviewing the file, it is noted that we have not received acknowledgement of the Information Disclosure Statement and cited art filed October 31, 2003. Enclosed are copies of the Information Disclosure Statement, PTO-1449 and stamped return postcard acknowledgement.


Applicants hereby respectfully request that:

- (1) the appropriately acknowledged PTO-1449 be furnished to Applicants; and

(2) the record be clarified to confirm that the cited art has been considered and made of record.

Respectfully submitted,

MCDERMOTT WILL & EMERY LLP



Michael E. Fogarty
Registration No. 36,139

600 13th Street, N.W.
Washington, DC 20005-3096
(202) 756-8000 MEF:cg
Facsimile: (202) 756-8087
Date: June 29, 2004

Applicant: Shigeki FURUYA, et al. Docket No. 60188-084

Title: CMOS BASIC CELL AND METHOD FOR FABRICATING SEMICONDUCTOR INTEGRATED CIRCUIT

Date Sent: 10/31/2003 ☐ Hand Carried ☐ Fax ☐ Electronic ☐ Cert. of Mailing ☐ Serial/Reg./Patent No. 09/922,671

☐ Transmittal Letter ☐ Express Mail No. ☐

New Patent App ☐ Utility ☐ Design ☐ Cont. ☐ CIP ☐ Div. ☐ PCT ☐ RCE ☐ Prov

Other: ☐ Letter submitting _____ pages of drawings

☐ pages of Claims ☐ Req. for Approval of Drawing Amendments

☐ pages of Abstract ☐ Req. for Oral Hearing

☐ pages of Formal/Informal Drawings ☐ Not. of Appeal ☐ Appeal Brief ☐ Reply Brief

☐ Small Entity ☐ Large Entity ☐ Rule 312 Amendment/Letter

☐ Declaration/Power of Attorney ☐ Req. for Acknowledgement of Cited Art

☐ Recordation of Assignment/Security Agreement ☐ Issue Fee

☐ Information Disclosure Statement ☐ Publication Fee

☒ 1 Form PTO 1449 ☐ Req. for Certificate of Correction

☐ 3 copies of cited references ☐ Maintenance Fee for _____ years after grant

☐ Preliminary Amendment ☐ Fee Address Indication Form

☐ Response to Missing Parts Notice ☐ Terminal Disclaimer

☐ Resp. to Notice to Correct App. Papers ☐ Petition to Commissioner

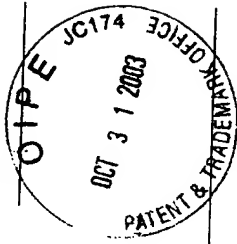
☐ Certified Copy of Priority Doc. ☐ Status Inquiry

☐ Claim for Convention Priority ☐ Other _____

☐ Response/Amendment to Office Action of _____

☐ Request for _____ month Extension of Time

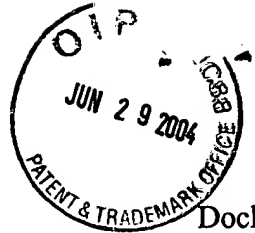
Check for \$ _____ Charge Deposit Acct. 5004-17\$ 0.00 Atty Init. _____ Tkpr. # 3328 Secy. or PL: JHarrison



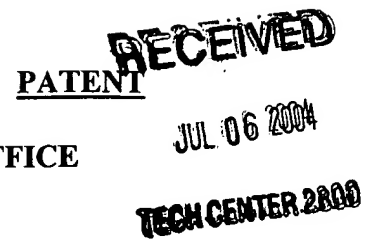
CMS Descrip.: _____

THE PATENT AND TRADEMARK OFFICE DATE STAMPED HEREON IS ACKNOWLEDGEMENT THAT THE ITEMS, CHECKED ABOVE, WERE RECEIVED BY THE PTO ON THE DATE STAMPED.

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JUL 06 2004
TECH CENTER 2800



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INFORMATION DISCLOSURE STATEMENT

Mail Stop DD
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached form PTO-1449. It is respectfully requested that the references be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

Each non-English language reference was first cited in a corresponding foreign application search report or office action and its relevance discussed therein. A copy of the

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foreign search report or office action, together with an English language version thereof, is attached for the Examiner's information.

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

MCDERMOTT, WILL & EMERY



Michael E. Fogarty
Registration No. 36,139

600 13th Street, N.W.
Washington, DC 20005-3096
(202) 756-8000 MEF:jgh
Facsimile: (202) 756-8087
Date: October 31, 2003

**RECEIVED**

JUL 06 2004

EXAMINER 2800

SHEET 1 OF 1

**INFORMATION DISCLOSURE
CITATION IN AN
APPLICATION**

(PTO-1449)

ATTY. DOCKET NO.
60188-084SERIAL NO.
09/922,671APPLICANT
Shigeki FURUYA, et al.FILING DATE
August 07, 2001GROUP
2815**U.S. PATENT DOCUMENTS**

EXAMINER'S INITIALS	CITE NO.	Document Number Number-Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		US			
		US			
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FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	CITE NO.	Foreign Patent Document Country Codes - Number - Kind Codes (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Figures Appear	Translation	
						Yes	No
	A	JP 09097885 with English abstract	04/08/1997	Denso Corp.			
		JP 61-202452 with English abstract	09/08/1986	Fujitsu Ltd.			
		JP 06-252367 with English abstract	09/09/1994	Siemens Ag			

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER'S INITIALS	CITE NO.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.

EXAMINER

DATE CONSIDERED

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.